thickness and the amount of platinum nanoparticles deposited is very low in comparison with commercial fuel cells (70% less).

Some factors beyond of carbon layer thickness used corroborated with low cell performance compared to a commercial fuel cell. As this study we evaluated the possibility of nanoparticles application, the gas flow control as well as humidification were not satisfactory to achieve maximum performance. Due to no correct control of humidity, the water concentration inside of membrane pores was very high and then the channels were clogged not allowing the gas flow. When the channels were free again, the flow gas passed easily increasing the current to approximately 0.8 ampere but the gas drag water again clogging the channel and decreasing the efficiency of cell.

V. CONCLUSION

The results obtained showed that the combination of pressure and adequate power is possible to control the size and shape of the nanoparticles while in addition the time influences the amount of deposited nanoparticles. Thus, one can obtain nanoparticles with sizes from 10 to 300 nm and well defined shapes arranged linearly allowing an increase in performance when considering application in fuel cells due to a better interaction of the gas with the catalyst – platinum. The results shown that using devices with better control of gas flow, humidification of the cell and temperature control can be achieved even higher performance, indicating the process the plasma as a good alternative to produce platinum nanoparticles for fuel cells.

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